

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Masahiko HATA et al.	Confirmation:	4111
Serial No.:	10/577,069	Art Unit:	2891
Filed:	June 20, 2006	Examiner:	J. Slutsker
For:	Method for manufacturing compound semiconductor substrate		

AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 15, 2009

Sir:

This Amendment responds to the Office Action of April 1, 2009. The response date has been extended by a three-month petition for extension of time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.